



PATENT APPLICATION

1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date September 20, 2004

In re the Application of

Kazuo ICHIKAWA et al.

Group Art Unit: 1763

Application No.: 09/670,877

Examiner: R. Zervigon

Filed: September 27, 2000

Docket No.: 107469

For: CVD SUBSTRATE AND CLEANING METHOD

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired August 19, 2004, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 158694 in the amount of \$110 in payment for:

<u>XX</u>	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
<u> </u>	Extension fee for response within second month pursuant to §1.136(a) (\$420.00)
<u> </u>	Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

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Respectfully submitted,


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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
